Application Data Sheet

Application Information

Application number:: Unassigned

Filing Date:: 02/13/2004

Application Type:: Regular

Subject Matter:: Utility

Suggested classification::

Suggested Group Art Unit::

CD-ROM or CD-R?:: None

Computer Readable Form (CRF)?:: No

Title:: APPARATUS AND METHOD FOR THIN-

LAYER METROLOGY

Attorney Docket Number:: 016790-0489

Request for Early Publication?:: No

Request for Non-Publication?:: No

Suggested Drawing Figure::

Total Drawing Sheets:: 5

Small Entity?:: No

Petition included?::

Secrecy Order in Parent Appl.?:: No

Applicant Information

Applicant Authority Type:: Inventor

Primary Citizenship Country:: Federal Republic of Germany

Status:: Full Capacity

Given Name:: Matthias

Family Name:: SLODOWSKI

City of Residence:: Jena

Country of Residence:: Germany

Street of mailing address:: Ricar 0774 Country of mailing address:: Germ					
Correspondence Information					
Correspondence Customer Number:: 22428					
E-Mail address::			PTOMailWashington@Foley.com		
Representative Information					
Representative Customer 2242		22428			
Number::					
Domestic Priority Information					
Application::	pplication:: Continuity Type		Parent	Parent Filing	
			Application::	Date::	
Foreign Priority Information					
Country::	Applicat	ion	Filing Date::	Priority Claimed::	
	number:	:			
Federal Republic of	103 08 2	58.1	02/25/2003	Yes	
Germany					
Assignee Information Assignee name:: LEICA MICROSYSTEMS JENA GmbH					
Assignee name			LEIGH MICHOS 131	FIND OF IAV GIIIDL	